



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Michael L. McSwiney, et al. § Group Art Unit:  
Serial No.: 10/764193 §  
Filed: January 23, 2004 § Examiner:  
For: Forming A Silicon Nitride Film § Atty. Dkt. No.: ITL.1056US (P17793)



Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Applicant submits the references listed on the attached form PTO 1449 together with any required copies of such references.

This statement is being filed before the receipt of a first Office action on the merits.

Please apply any charges or credits to Deposit Account 20-1504 (ITL.1056US).

Respectfully submitted,

Date: April 26, 2004

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Date of Deposit:	<u>April 26, 2004</u>
I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as <b>first class mail</b> with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	
Rebecca R. Ginn	

			ATTY DOCKET NO.		SERIAL NO.		
			ITL.1056US (P17793)		10/764,193		
			APPLICANT(S): MICHAEL MCSWINEY, ET AL.				
			FILING DATE:	GROUP ART UNIT:			
			January 23, 2004				
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A.						
	B.						
	C.						
	D.						
	E.						
	F.						
	G.						
	H.						
	I.						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES      NO
	J.						
	K.						
	L.						
	M.						
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
	N.	Inventors: Michael L. McSwiney and Michael D. Goodner, Patent Application entitled: <i>Low-Temperature Silicon Nitride Deposition</i> , filed July 30, 2003, Serial No. 10/631,627, Patent Application has 15 pages and 4 pages of drawings					
	O.	Author: SCHUMACHER, A UNIT OF AIR PRODUCTS AND CHEMICALS, INC.; entitled: <i>BTBAS Silicon Nitride</i> ; 1 page; <a href="http://www.schumacher.com/btbas">www.schumacher.com/btbas</a> , date unknown.					
	P.						
	Q.						
	R.						
	S.						
	T.						
EXAMINER				DATE CONSIDERED			
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>							